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Bib Data Sheet

CONFIRMATION NO. 3893

SERIAL NUMBER 10/019,407	FILING DATE 03/25/2002 RULE	CLASS 438	GROUP ART UNIT 2813	ATTORNEY DOCKET NO. 520.41003 X00
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APPLICANTS

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** CONTINUING DATA *****

This application is a 371 of PCT/JP00/04141 06/23/2000

** FOREIGN APPLICATIONS *****

JAPAN 11/181559 06/28/1999

Foreign Priority claimed

☒ yes ☐ no

35 USC 119 (a-d) conditions met

☒ yes ☐ no ☐ Met after Allowance

Verified and Acknowledged

Examiner's Signature: *[Signature]* Initials: *[Initials]*

STATE OR

COUNTRY
JAPAN

SHEETS

DRAWING
16

TOTAL

CLAIMS
20

INDEPENDENT

CLAIMS
9

ADDRESS

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TITLE

Polysilicon semiconductor thin film substrate, method for producing the same, semiconductor device, and electronic device

FILING FEE

RECEIVED

FEES: Authority has been given in Paper
 No. _____ to charge/credit DEPOSIT ACCOUNT
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☐ All Fees☐ 1.16 Fees (Filing)☐ 1.17 Fees (Processing Ext. of time)

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